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500.41316VX1

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant(s): T. KAJI, et al  
Serial No.: ~~40/090,759~~ 10/659,394  
Filed: September 11, 2003  
For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS  
AND PLASMA PROCESSING METHOD USING IT  
Group: 1763  
Examiner: P. Hassanzadeh

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

September 8, 2004

Sir:

In response to the Office Action dated June 8, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Specification;

Amendment of the Claims; and

Remarks are included following the amendments.